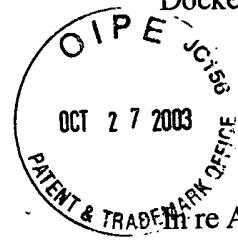


Docket No.: 2328-049

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Tuqiang NI

U.S. Patent Application No. 09/689,616

Filed: October 13, 2000

: : EXPEDITED PROCEDURE  
: : Response under 37 CFR 1.116  
:  
:  
: Group Art Unit: 1763  
:  
: Examiner: ALEJANDRO MULERO,  
LUZ L.

For: ETCH CHAMBER WITH HYBRID PLASMA SOURCE

AMENDMENT UNDER RULE 116

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is submitted in reply to the Office Action mailed August 23, 2003, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.

**Certificate of Mailing**

I hereby certify this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: (Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450)

On October 23 2003  
Jean C.